



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2822
Examiner: Bac H. Au

In Re PATENT APPLICATION OF

Applicant : Hiroomi TSUTAE

Appln. No. : 10/657,207

Conf. No. : 9107

Filed : September 9, 2003

For : PROCESS OF CLEANING
A SEMICONDUCTOR
MANUFACTURING SYSTEM AND
METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE

Atty. Dkt. : FUJI 136

AMENDMENT

October 29, 2008

MAIL STOP – AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner Au:

This Amendment is responsive to the Office Action mailed, June 30, 2008.

Amendments to the Claims are shown in a listing of the claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

Reconsideration of the subject Application is requested in view of the following amendments and remarks.